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[10191/3939]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors : Andrea URBAN et al.
Serial No. : 10/520,886
Filed : July 21, 2005
For : A LAYER SYSTEM COMPRISING A SILICON LAYER
AND A PASSIVATING LAYER, A METHOD FOR
PRODUCING A PASSIVATING LAYER ON A SILICON
LAYER AND THEIR USE
Examiner : Laura Mary MENZ
Art Unit : 2813
Confirmation No. : 7030

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

Date: June 5, 2009

Reg. No. 36,197

Signature: _____

Jong H. Lee

AMENDMENT IN RESPONSE TO QUAYLE ACTION

SIR:

In response to the Quayle Office Action mailed on April 28, 2009, Applicants respectfully submit the following amendments and remarks.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.